

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fumihiko Nakamura, et al.

Application No. 09/925,153

Filed: August 8, 2001

For: "INSULATING NITRIDE LAYER
AND PROCESS FOR ITS FORMING, AND
SEMICONDUCTOR DEVICE AND
PROCESS FOR ITS PRODUCTION"

Group Art Unit 2813

Examiner: D. Blum



I hereby certify that this document is being deposited
with the United States Postal Service as first class mail
in an envelope addressed to Commissioner of Patents,
Alexandria, VA 22313-1450 on May 5, 2003.

Karen Turkowski
Karen Turkowski

RECEIVED
MAY 14 2003
TC 2800 MAIL ROOM

Commissioner of Patents
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136

Dear Sir:

Applicant hereby petitions the Commissioner of Patents and Trademarks to extend the period for response to the office Action dated November 5, 2002, for three month(s) so that the period for response is extended to May 5, 2003.

The Commissioner is hereby authorized to charge the amount of \$930.00 to cover the three-month extension fee to American Express Account No. 3785-716974-01002 CH and to charge any deficiency to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Dated: May 5, 2003

By: *Christopher P. Rauch*
Christopher P. Rauch
Registration No. 45,034
SONNENSCHNEIN NATH & ROSENTHAL
P.O. Box 061080
Wacker Drive Station, Sears Tower
Chicago, Illinois 60606-1080
(312) 876-8000
Customer #26263

05/13/2003 SSESHE1 00000090 09925153
02 FC:1253 930.00 OP